

# Trial Transcript

2010 WL 8696196 (D.Del.) (Trial Transcript)

United States District Court, D. Delaware.

← Citation

S.O.I.TEC Silicon on Insulator Technologies, S.A. and Commissariat a l'Energie Atomique,

Plaintiffs - Counterclaim Defendants,

← Party Name

v.

MEMC ELECTRONIC MATERIALS, INC., Defendant - Counterclaim Plaintiff.

No. 08CV00292. ← Docket

October 27, 2010.

**Testimony of Plaintiff's Witness, Dr. Thierry Poumeyrol** ← Document Title

Attorney

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Senniger Powers, LLP by: [Robert M. Evans, Jr.](#), Esq., Marc W. Vander Tuig, Esq., [David W. Harlan](#), Esq. and [Richard Brophy](#), Esq. (St. Louis, Missouri).

Judge

Before: Hon. [Sue L. Robinson](#).

THE COURT: Good morning, ladies and gentleman. Thanks for coming out in this awful weather.

And Mr. Brody, I will let you proceed.

MR. BRODY: Thank you, your Honor.

Text

Your Honor, our first witness is going to be Dr. Thierry Poumeyrol. Dr. Poumeyrol was a Ph.D. student at the laboratory where Dr. Bruel and Aspar, the other inventors on the '009 patent, worked. And he's the guy who actually, for the first time, transferred a complete layer of complete thin film from the surface of a wafer to another substrate by mechanically pulling it apart, and he'll describe to you exactly how he did that.

He's the first of the witnesses we'll put on today. This is, of course, our chance to tell you our side of the story.

We're going to have some other witnesses, including our expert witness, who will talk to you about these issues.

We're going to be putting on evidence with respect to the validity of the '009 patent, to respond to the evidence that you heard from Dr. Averback and the other witnesses. We're not going to be putting on evidence as to whether or not MEMC